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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of)
Shunpei YAMAZAKI, et al.)
Serial No. 08/691,434) Group Art Unit: 2822
Filed: 08/02/1996) Examiner: Mary Wilczewski
For: METHOD OF FABRICATING)
SEMICONDUCTOR DEVICES AND APPARATUS)
FOR PROCESSING A SEMICONDUCTOR)

**REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents
P. O. Box 1450
Alexandria VA 22313-1450
Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
Class Mail in an envelope addressed to: Commissioner for Patents,
P. O. Box 1450, Alexandria VA 22313-1450, on December 1, 2004

Penny L. Dunn

Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee Due
form mailed November 3, 2004 acknowledging the filing of an Information Disclosure
Statement on June 9, 2004.

The Notice of Allowability did not, however, include an initialed Form PTO-1449
acknowledging the Information Disclosure Statement filed October 21, 2004. Also, upon
further review, it was noted that reference JP03-024717 on page 2 of 5 of the Information
Disclosure Statement filed July 1, 1998 was not initialed by the Examiner. The same IDS
contains several references that were initialed and lined through without explanation from the
Examiner. Therefore, it is respectfully requested that the Examiner evidence consideration
of the references cited in the IDS of October 21, 2004 and July 1, 1998 by providing a copy of
the initialed Form PTO-1449.

If a conference would be beneficial in expediting the prosecution of the instant
application, the Examiner is invited to telephone the undersigned to arrange such a
conference.

Respectfully submitted,


Eric J. Robinson
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